

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori, et al.
Serial No. : 10/713,275
Filed : November 17, 2003
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF
MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM
TRANSISTOR

Art Unit : 2822
Examiner : Kiesha L. Rose

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form.
Copies of any listed U.S. patents or U.S. patent application publications can be provided upon
request.

No fee is believed to be due in connection with the filing of this paper on the Electronic
Filing System (EFS). In the event that any fees are due, please apply any charges or credits to
deposit account 06-1050.

Respectfully submitted,

Date: 2/21/06


John F. Hayden
Reg. No. 37,640

Customer No. 26171
Fish & Richardson P.C.
1425 K Street, N.W. - 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331
/adt
40328604.doc

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-024004	Application No. 10/713,275
	Applicant Isamu Kobori, et al.		
	Filing Date November 17, 2003	Group Art Unit 2822	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2003-0036222	02/20/2003	Takemura			09/26/2002
	AB	2003-0116766	06/26/2003	Zhang			12/03/2002
	AC	5,403,762	04/04/1995	Takemura			06/28/1994
	AD	5,717,224	02/10/1998	Zhang			09/06/1996
	AE	5,904,509	05/18/1999	Zhang et al.			12/30/1994
	AF	5,990,491	11/23/1999	Zhang			12/10/1997
	AG	6,051,453	04/18/2000	Takemura			09/05/1996
	AH	6,071,764	06/06/2000	Zhang et al.			06/28/1995
	AI	6,146,930	11/14/2000	Kobayashi et al.			12/10/1997
	AJ	6,391,694	05/21/2002	Zhang et al.			02/25/1999
	AK	6,501,097	12/31/2002	Zhang			09/17/1999

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	